

TRANSMITTAL OF FORMAL DRAWINGS

Docket No.

FIS920040027US1 (17404)

Inventor(s) Application Of: Kevin K. Chan, et al.

Application No.	Filing Date	Confirmation No.	Examiner	Customer No.	Group Art Unit
10/710,737	July 30, 2004	Unassigned	Unassigned	23389	Unassigned

Invention: CHEMICAL TREATMENT TO RETARD DIFFUSION IN A SEMICONDUCTOR OVERLAYER

Address to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Transmitted herewith are:

4 sheets of formal drawing(s) for this application.

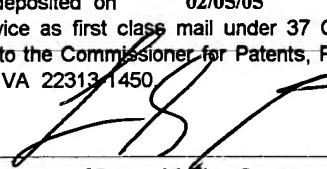
Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

Signature

Leslie S. Szivos, Ph.D.
Registration No. 39,394

Dated: February 4, 2005

I certify that this document and attached formal drawings are being deposited on 02/05/05 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



Signature of Person Mailing Correspondence

Leslie S. Szivos, Ph.D.

Typed or Printed Name of Person Mailing Correspondence